IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Heidi Cao et al.	Art Unit:	1795
Serial No.:	10/686,031	Examiner:	Amanda C. Walke
Filed:	October 14, 2003	Assignee:	Intel Corporation
Title:	PHOTORESISTS WITH REDUCED OUTGASSING FOR EXTREME ULTRAVIOLET LITHOGRAPHY		

MAIL STOP AF
Commissioner For Patents
P.O. Box 1450
Alexandria, Va 22313-1450

AMENDMENT

Please reconsider this application in light of the following:

Amendments to the Claims in the **Listing of Claims** beginning on page 2; and

Remarks beginning on page 10.